

**Notice of References Cited**

Application/Control No.

09/995,575

Applicant(s)/Patent Under  
Reexamination  
YASUMOTO, TAMIHIDE

Examiner

Erik Kielin

Art Unit

2813

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Van Zant, Microchip Fabrication, 4th ed, McGraw_Hill: New York, 2000, p. 34.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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